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NO. 8183 P. 2/18

OK TO ENTER: /M.L.P./

01/08/2013

Docket No. 740756-945

was considered with 11/17/2006 action

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re U.S. Patent application:
Hisato SHINOHARA et al.
Application Serial No. 08/169,127
Filed: December 20, 1993
For: LASER IRRADIATION METHOD
(AS AMENDED)

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)
) Art Unit: 1762
) Examiner: Marianne L. Padgett
) Date: August 25, 2006

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SUPPLEMENTAL AMENDMENT

Mail Stop AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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Sir:

Further to the Amendment filed June 27, 2006, please consider the following amendments and remarks in connection with this instant application.

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Pamela L. Padgett